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Assistant Commissioner for Patents
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PATENT
Attorney Docket No.: A4231/T34400
Client Ref. No.
004231/USA/DD/HDP/CVD/JW

On June 29, 2001

TOWNSEND and TOWNSEND and CREW LLP

By: Anna L. McNeill

30879 U.S. PTO
09/920891
08/02/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michael Kwan, et al.

Application No.: 09/648,395

Filed: September 24, 2000

For: GAS CHEMISTRY CYCLING TO
ACHIEVE HIGH ASPECT RATIO
GAPFILL WITH HDP-CVD

Examiner: Ghyka, G.

Art Unit: 2812

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT UNDER 37
CFR §1.97 and §1.98

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The reference cited on attached form PTO-1449 is being called to the attention of the Examiner. A copy of the reference is enclosed. It is respectfully requested that the cited reference be expressly considered during the prosecution of this application, and the reference be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and

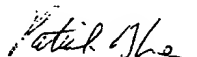
no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

This IDS is being filed after the mailing date of the Notice of Allowance.

Enclosed is a Petition requesting consideration of this IDS.

Please deduct any necessary fees from, or credit any overpayment to, the undersigned's Deposit Account No. 20-1430.

Respectfully submitted,


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